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PATENT
8565-7213 (81839.0077)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Filed: December 22, 1998

For: SILICON WAFER STORAGE WATER AND SILICON
WAFER STORAGE METHOD

Art Unit: 1744

Examiner: E.L. McKane

Box Non-Fee Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.
- ☐ A Notice Of Change Of Attorney's Address and Associate Power Of Attorney is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

he fee has been calculated as shown below.

	(Col. 1) CLAIMS REMAINING AFTER AMENDMENT		(Col. 2) HIGHEST NUMBER PREVIOUSLY PAID FOR	(Col. 3) PRESENT EXTRA*	LG/SM \$ ENTITY FEE		ADD'L FEE DUE
TOTAL CLAIMS FEE	10	-	20 **	0	LG=\$18 SM=\$9	\$18	\$ 0
INDEPENDENT CLAIMS FEE	3	-	5 ***	0	LG=\$84 SM=\$42	\$84	\$ 0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIMS					LARGE ENTITY FEE = \$280 SMALL ENTITY FEE = \$140		\$ 0
TOTAL							\$ 0

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box on Col. 1 of a prior amendment or the number of claims originally filed.

- ☐ A check in the amount of \$ 0 to cover the additional claims fee is enclosed. **A copy of this sheet is enclosed.**
- ☐ A check in the amount of \$ 0 to cover the extension fee is enclosed. **A copy of this sheet is enclosed.**
- ☒ The Commissioner is hereby authorized to charge any deficiencies of fees associated with this communication or credit any overpayment to Deposit Account No. 50-1314. **A copy of this sheet is enclosed.**
- ☒ Any filing fees under 37 C.F.R. 1.16 for the presentation of extra claims
- ☒ Any patent application processing fees under 37 C.F.R. 1.17

Respectfully submitted,
HOGAN & HARTSON L.L.P.

By:

John P. Scherlach

Registration No. 23,009

Attorney for Applicant(s)

Date: September 19, 2003

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Appl. No. 09/218,997

Amdt. Dated: September 19, 2003

Reply to Office Action of June 19, 2003

Attorney Docket No. 8565D-7213 (81839.0077)

Customer No. 26021



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Confirmation No.: 2370

Filed: December 22, 1998

For: SILICON WAFER STORAGE WATER
AND SILICON WAFER STORAGE
METHOD

Art Unit: 1744

Examiner: McKane, E.L.

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9/27/03

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P.O. Box 1450
Alexandria, VA 22313-1450

September 19, 2003

Date of Deposit

John P. Scherlach, Reg. No. 23,009

Name

John P. Scherlach 09/19/03

Signature

Date

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of June 19, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the Listing Of Claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.